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(54) **COUPLING ELEMENT ALIGNMENT USING WAVEGUIDE FIDUCIALS**

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G02B 6/42 (2006.01)
G02B 6/10 (2006.01)

(52) **U.S. Cl.** **385/52**; 385/31; 385/33; 385/39; 385/51; 385/129; 385/130; 385/131

(58) **Field of Classification Search** 385/52, 385/33

See application file for complete search history.

(56) **References Cited**

U.S. PATENT DOCUMENTS

5,898,803 A * 4/1999 Mueller-Fiedler et al. 385/36

6,236,788 B1 *	5/2001	Moisel	385/52
6,754,407 B2	6/2004	Chakravorty	
6,934,429 B2 *	8/2005	Kikuchi et al.	385/14
6,973,248 B2 *	12/2005	Kropp	385/131
7,212,698 B2 *	5/2007	Bapst et al.	385/14
2005/0117833 A1 *	6/2005	Fukuzawa et al.	385/14
2005/0176161 A1 *	8/2005	Bapst et al.	438/31
2006/0263003 A1 *	11/2006	Asai et al.	385/14

OTHER PUBLICATIONS

Schnitzer et al , "High performance VCSEL arrays for optical inter-connection" Electronic Components and Technology Conference, pp. 762-770 (May 1998).

* cited by examiner

Primary Examiner—Frank G Font

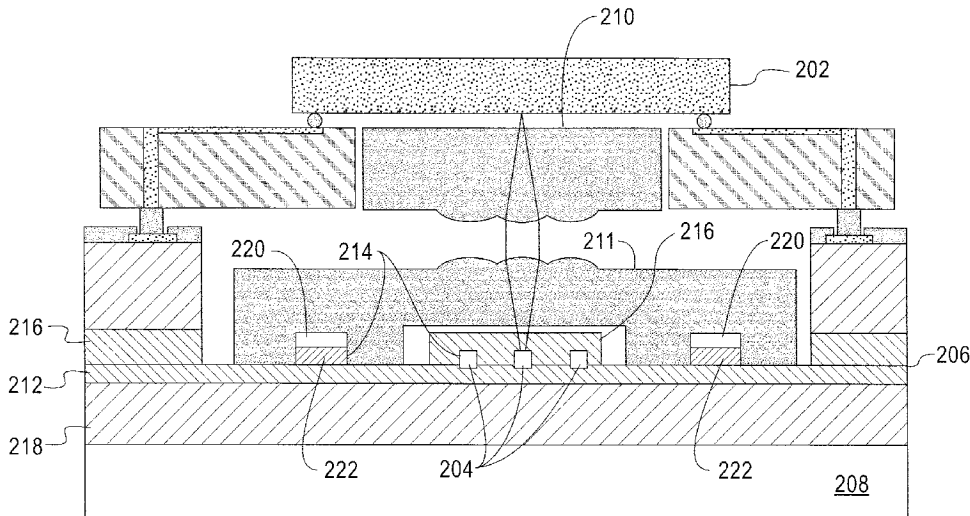
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(57) **ABSTRACT**

An optical assembly includes a waveguide assembly and an optical coupling element. The waveguide assembly includes a core, a cladding portion, and, preferably, at least two waveguide core fiducials, the at least two waveguide core fiducials and the core being lithographically formed substantially simultaneously in a substantially coplanar layer. The core and the at least two waveguide core fiducials are formed in a predetermined relationship with the cladding portion. The optical coupling element (for example, a lens array or mechanical transfer (MT) ferrule), includes an optical element and, preferably, at least two alignment features associated with the optical element, the at least two alignment features being mated with the at least two waveguide core fiducials to accurately position the optical element with respect to the core in an X-Y plane A method of alignment is also provided.

5 Claims, 6 Drawing Sheets



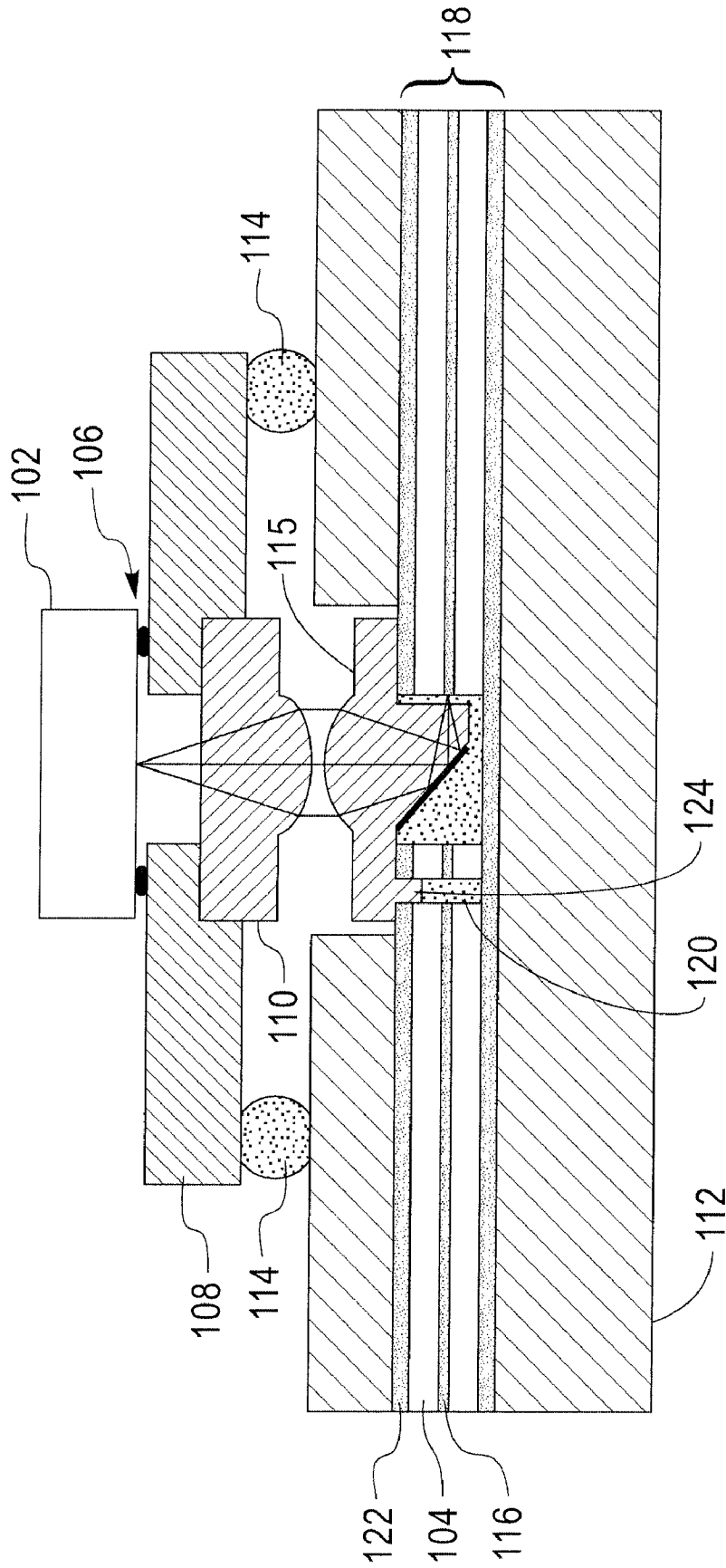


FIG. 1
Prior Art

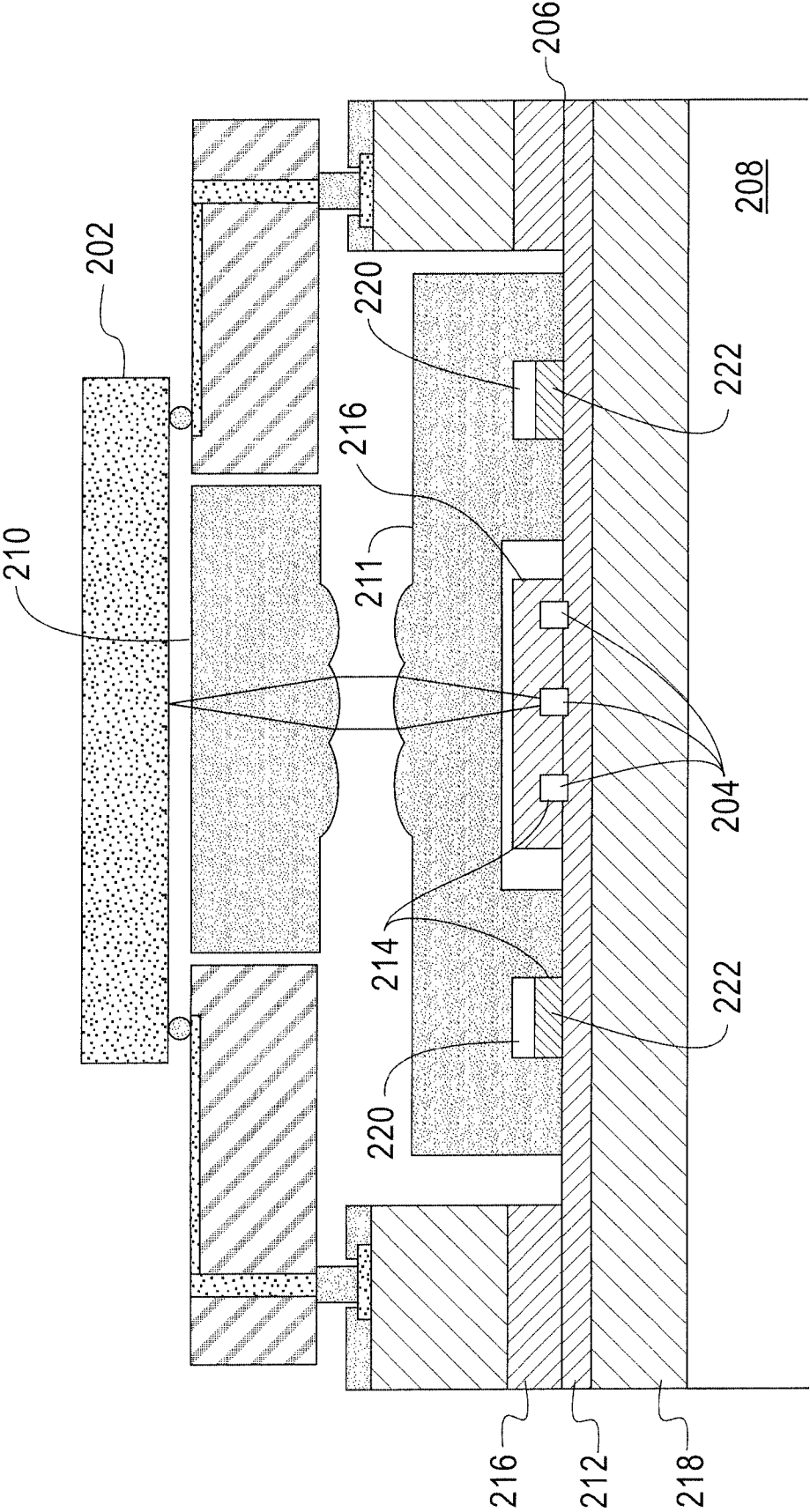


FIG. 2

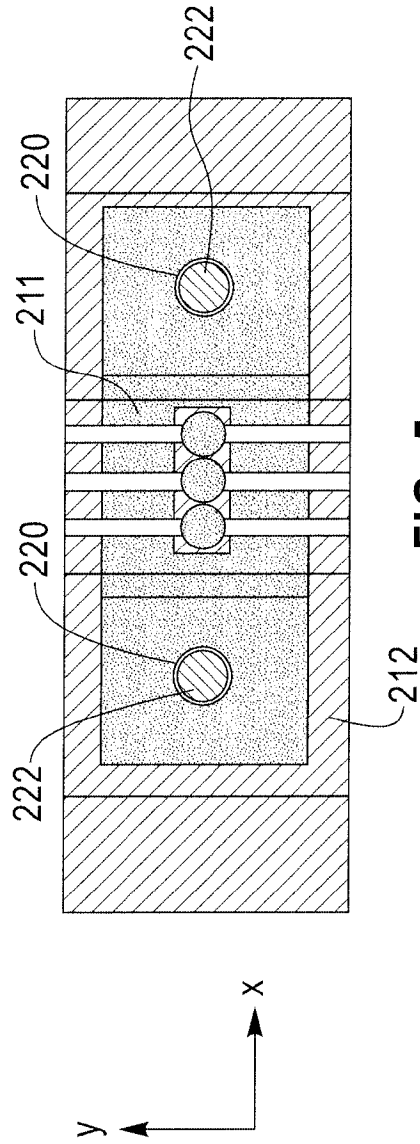


FIG. 5

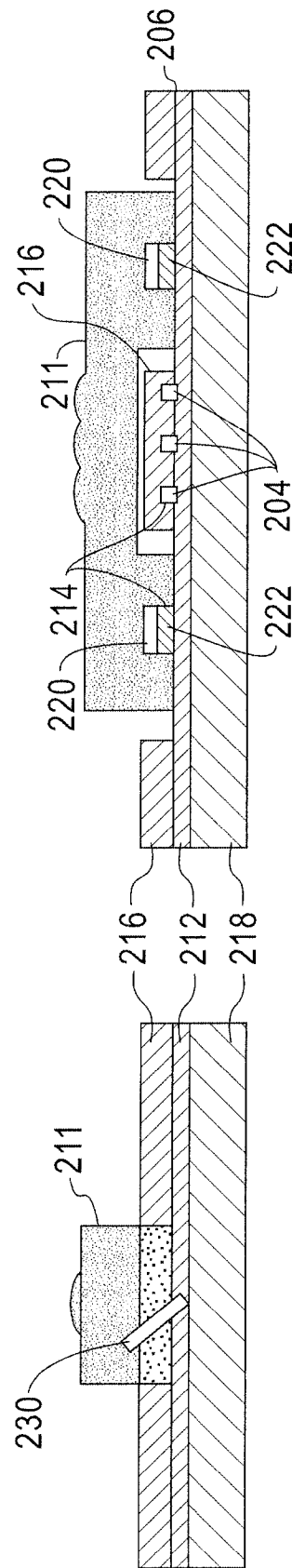


FIG. 4

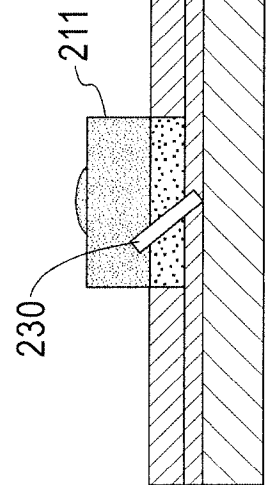


FIG. 3

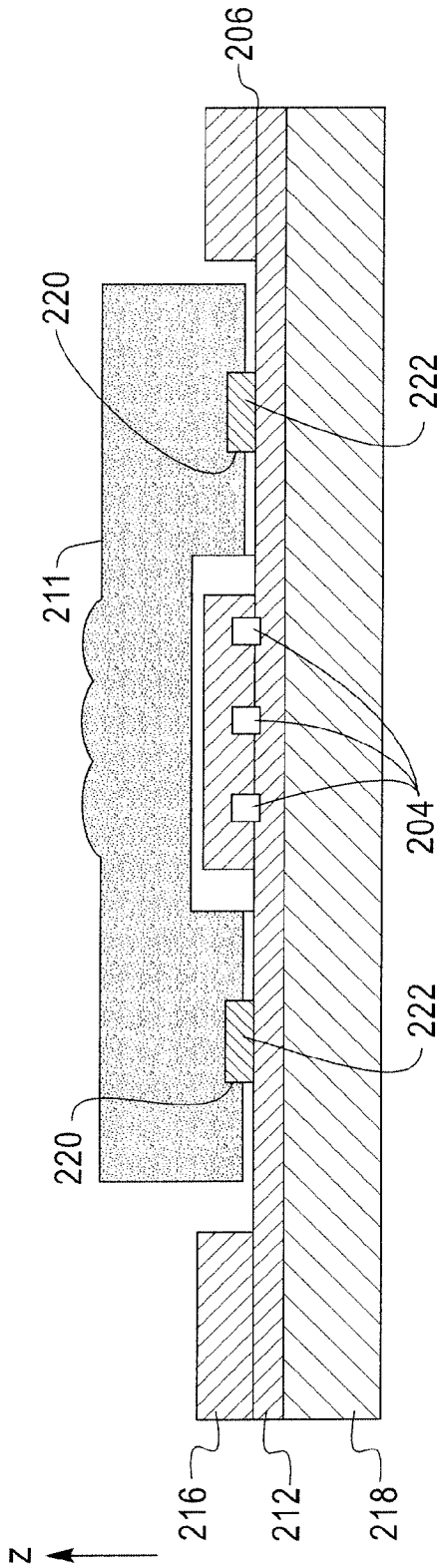


FIG. 6

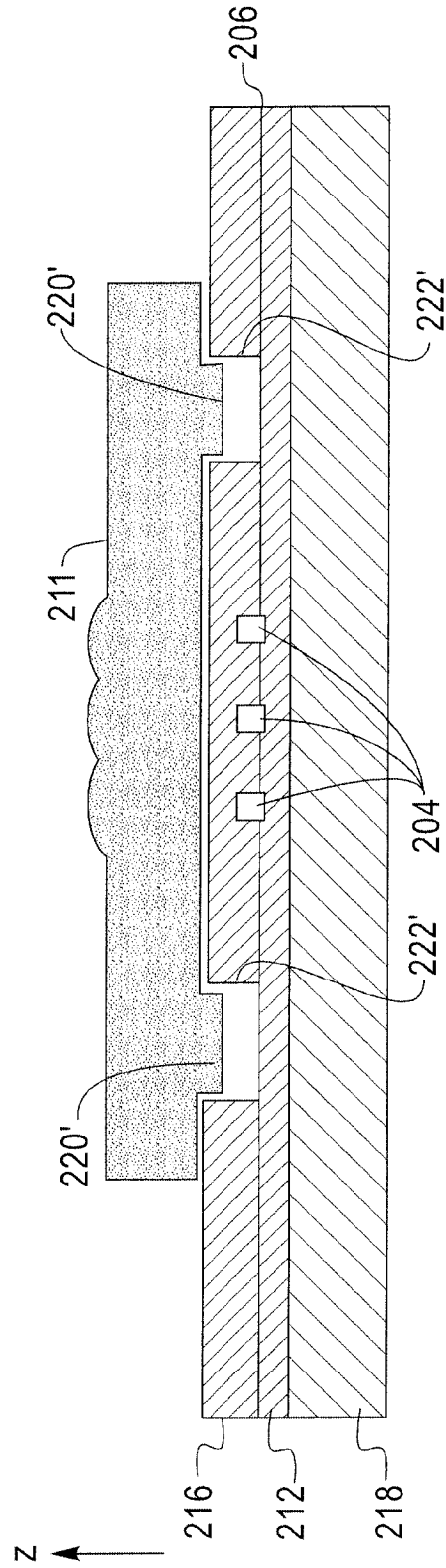


FIG. 7

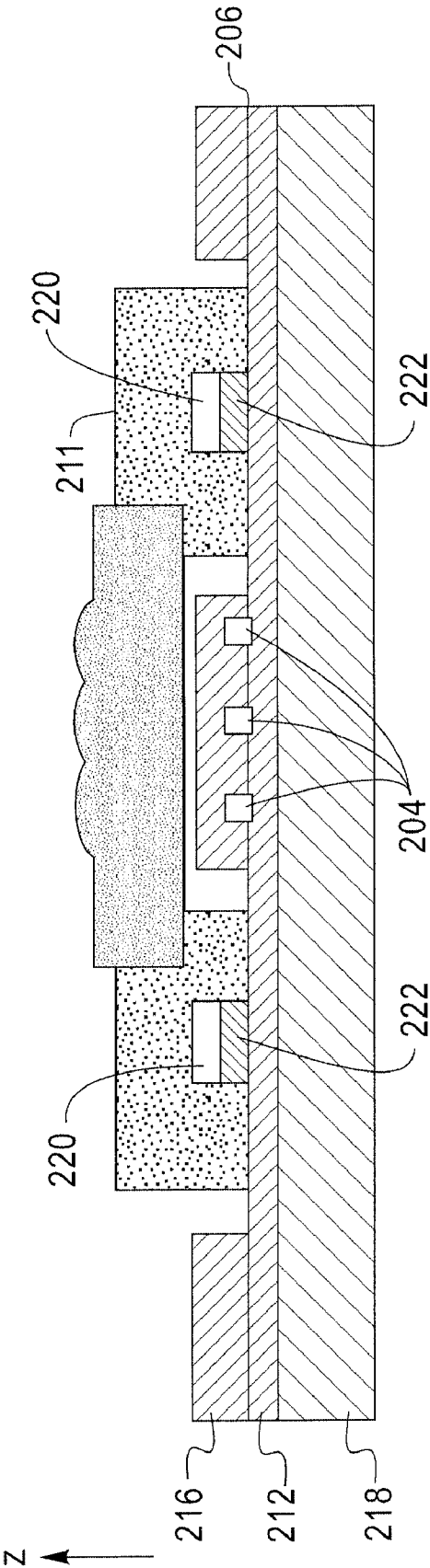


FIG. 8

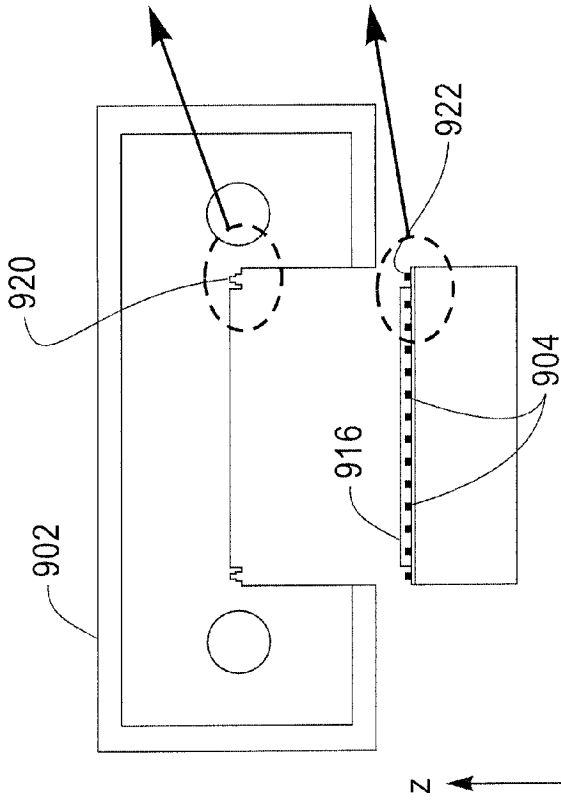
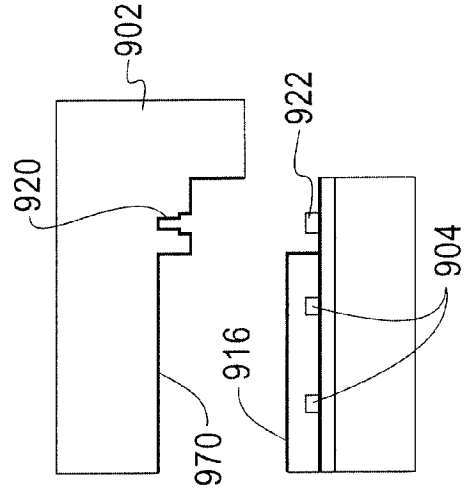


FIG. 9

FIG. 10

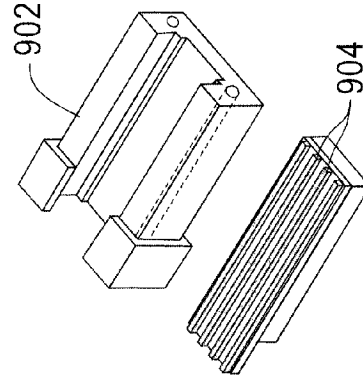


FIG. 11

Accurate XY alignment realized

FIG. 10

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COUPLING ELEMENT ALIGNMENT USING WAVEGUIDE FIDUCIALS

CROSS-REFERENCE TO RELATED APPLICATIONS

This application is a continuation of U.S. patent application Ser. No. 11/733,406, filed Apr. 10, 2007, now U.S. Pat. No. 7,421,160 the complete disclosure of which is expressly incorporated by reference herein in its entirety for all purposes.

FIELD OF THE INVENTION

The present invention generally relates to the electrical, electronic, and optical arts and, more particularly, to techniques for aligning optical coupling elements to waveguide cores.

BACKGROUND OF THE INVENTION

The reliable, accurate and cost-effective integration of optical coupling elements and optical connectors with waveguides structures is a challenge. The performance of high-end computer systems continues to be limited less by microprocessor clock speeds and more by the interconnections between microprocessors. As data rates increase, traditional copper links are limited to shorter distances, especially in the face of power constraints and high aggregate bandwidths. For board-to-board and rack-to-rack interconnects, the edge connector density is starting to limit the overall throughput. The incorporation of highly-parallel optical data links into these systems could offer superior performance in terms of density, power dissipation and cost.

Parallel optical modules include arrays of silicon circuitry connected to optoelectronic (OE) devices implemented using III-V semiconductors. These modules may be positioned in close proximity to a printed circuit board that may contain one or more optical waveguide channels. The light can be coupled into the waveguides, and then easily routed across the circuit board to other optical modules. The waveguides may be on the top of the board or embedded within the board. This embedded waveguide arrangement, shown in FIG. 1, is similar to the one described in Khakravoity et al., "Flip-Chip Package Integrating Optical and Electrical Devices and Coupling to a Waveguide on a Board," U.S. Patent Application Publication 2003/0002770A1, Jan. 2, 2003.

In the past, the alignment between the OE devices (or lens arrays) and the waveguide cores were realized by actively aligning the OE or coupling elements through the use of sophisticated tooling; powering up the OE devices, and monitoring the light coupled into the waveguide core. This process was time consuming and costly.

Referring now to FIG. 1, there is depicted therein a cross-sectional view of the optical coupling between an OE module **102** and the core layer **116** of a polymer waveguide film, according to the prior art. In this case, an OE device array **106** is supported on a carrier substrate **108** that also contains a collimating lens array element **110**. This assembly, also known as the OE module, is attached to the PCB substrate **112** by a solder ball grid array (BGA), pin grid array, land grid array, or other techniques, all of which are suggested by ball elements **114**. Light from the OE module **102** is gathered by the waveguide lens array coupling element **115** and focused into the core **116** of an optical waveguide **118** formed by core **116** and cladding **104**. Depending upon the size of the waveguide core **116**, the waveguide lens array **115** must be

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centered with respect to the core **116** to within 5 to 10 microns. In this case an alignment hole **120** (precisely aligned to the waveguide core **116**) was fabricated in a copper layer **122** adjacent to the waveguide layer **118**. The process to fabricate this alignment hole **120** requires precise and accurately tooling leading to increased process complexity and cost. Next, the waveguide lens array **115** with its corresponding alignment pin **124** is placed on top of the waveguide layer **118** and its alignment pin **124** inserted into the alignment hole **120**. Thus, precise alignment of the waveguide lens array assembly **115** is realized, however, fabrication of the waveguide reference hole **120** required substantial time and expense.

Accordingly, it would be desirable to overcome the limitations of prior art approaches.

SUMMARY OF THE INVENTION

Principles of the present invention provide techniques for aligning optical coupling elements to waveguide cores. An exemplary embodiment of an optical assembly, according to one aspect of the invention, includes a waveguide assembly and an optical coupling element. The waveguide assembly includes a core, a cladding portion, and (preferably) at least two waveguide core fiducials, the at least two waveguide core fiducials and the core being lithographically formed substantially simultaneously in a substantially coplanar layer. The core and the at least two waveguide core fiducials are formed in a predetermined relationship with the cladding portion. The optical coupling element (for example, a lens array or mechanical transfer, (MT) ferrule), includes an optical element and at least two alignment features associated with the optical element, the at least two alignment features being mated with the at least two waveguide core fiducials to accurately position the optical element with respect to the core in an X-Y plane. In some instances, a single fiducial and a single alignment feature can be employed.

In another aspect, an exemplary method for aligning an optical coupling element to a waveguide core, according to another aspect of the invention, includes the step of providing a waveguide assembly, the waveguide assembly comprising a core, a cladding portion, and (preferably) at least two waveguide core fiducials lithographically formed substantially simultaneously with the core. The core and the at least two waveguide core fiducials are formed in a predetermined relationship with the cladding portion. The method also includes the step of providing an optical coupling element (for example, a lens array or MT ferrule), the optical coupling element including an optical element and at least two alignment features associated with the optical element. The at least two alignment features are configured to mate with the at least two waveguide core fiducials and to accurately position the optical element with respect to the core in an X-Y plane. The method further includes the step of plugging the at least two waveguide core fiducials and the at least two alignment features together, whereby the waveguide core and the optical coupling element are accurately positioned in the X-Y plane. Again, in some instances, a single fiducial and a single alignment feature can be employed.

One or more embodiments provide a practical, accurate, and low cost technique and structure to align optoelectronic (OE) devices, lens arrays, and other connector elements to polymer waveguide optical interconnect materials. One or more exemplary embodiments utilize lithographic features that are patterned at the same time as the waveguide core to very accurately establish mechanical alignment fiducials. By

using these fiducials during the assembly of the waveguide's connector elements, an extremely accurate assembly is realized in a passive manner.

These and other objects, features and advantages of the present invention will become apparent from the following detailed description of illustrative embodiments thereof, which is to be read in connection with the accompanying drawings.

BRIEF DESCRIPTION OF THE DRAWINGS

FIG. 1 is an illustration of the optical coupling between an OE module and waveguides embedded in a printed circuit board, according to prior-art techniques;

FIG. 2 is a side view illustration, showing the passive alignment of a microlens array assembly to a polymer waveguide layer; according to one example of the invention;

FIGS. 3-5 are, respectively, side, front, and top view illustrations showing the passive alignment of a microlens array assembly to a polymer waveguide layer, according to one example of the invention;

FIGS. 6-8 show alternate exemplary approaches for referencing the microlens assembly to the waveguide layer; and

FIGS. 9-11 show the passive alignment of a connector element to the waveguide layer according to one example of the invention.

DETAILED DESCRIPTION OF PREFERRED EMBODIMENTS

Exemplary apparatuses and methods will now be described with respect to the figures, in which like reference characters are used throughout to refer to like elements, unless otherwise noted. With reference to FIG. 2, such figure shows a cross-sectional view of the inventive optical coupling between an OE module 202 and the core layer 204 of a polymer waveguide film 206 embedded in a printed circuit board 208, according to an exemplary embodiment of the invention. The orientation of the waveguide film 204 has been rotated such that the light path within the waveguide core is viewed "end-on" in the figure; additionally the waveguide light turning mirror is not shown for clarity reasons. As in FIG. 1, the light from the OE module 202 (including lenses 210) is gathered by the waveguide lens array assembly 211 and focused into the individual waveguide cores 204. Once again, the waveguide lens array assembly 211 must be aligned with respect to the waveguide cores 204 to a given degree of precision, typically 5 microns, depending upon several factors such as core size, waveguide numerical aperture (NA), Vertical-Cavity Surface-Emitting Laser (VCSEL) source size, etc. The waveguide film is typically formed of several layers, such as a lower cladding layer 212 (acting as a base), a core layer 214 (to carry the signal light), and sealed by a top cladding layer 216. The index contrast between the core 214 and the cladding 216 enables the light to be confined within the core by means of total internal reflection (as set forth below, layer 214 includes both cores 204 and fiducials 222 to be discussed). The fabrication of the waveguide film stack typically begins with the deposition of the lower clad layer 212 on a base substrate 218. This lower clad layer 212 helps to planarize the substrate 218 and provide a smooth base for the core layer 214. Next the core layer 214 is applied. The core material may be applied to the lower clad layer 212 by either spray coating or doctor blading. Next the core material 214 is patterned. Typically the core layer is exposed to UV light through a proximity photomask or by optical projection techniques, thus defining the waveguide core pattern with cores 204 and

fiducials 222. Next, unexposed regions on the core layer are removed by means of a developer. Finally a top clad layer 216 is applied to seal the photo-defined cores 204.

In one or more embodiments of the invention, additional features are defined in the core layer 214 at the same time that the light carrying cores 204 are defined. These additional features may be used to provide an accurate positional reference for the subsequent attachment of waveguide coupling elements, such as a waveguide lens array coupling element 211. As shown in FIG. 2, these additional core features, also referred to as waveguide core fiducials 222, may be positioned adjacent to the waveguide core (light signal carrying) region 204. These fiducials 222 may be of varied size and shape. Since they are defined at the same time as the waveguide cores, the positional accuracy between the cores 204 and the core fiducials 222 is defined by the accuracy of the lithographic process, typically much better than 1 micron. After development and curing of the waveguide core layer, a top clad layer 216 is applied (by means of doctor blading or spray coating) on top of the film stack. This top clad layer may also be photo-patterned; in this case the top clad material is removed in the region above the waveguide core fiducials 222. This material is removed so that the mating coupling elements (in this example, recesses 220 of lens 211) may directly access the waveguide core fiducials 222. At this point, the waveguide film stack is complete.

Next, as shown in FIG. 2, a waveguide lens array assembly 211 is attached to the waveguide film layer 206. The waveguide lens array assembly incorporates its own mating fiducials 220 with mate with corresponding fiducials 222 on the waveguide stack. The waveguide lens array assembly 211 may be fabricated by precision injection molding of optically transparent polymer, or other techniques, leading to a highly accurate and low cost assembly. The placement of the lens array assembly 211 to the waveguide layer 206 is done in a simple manner without the need to actively align these parts by hand or other mechanical means. An adhesive may be used to hold the lens assembly in place 211. Hence the coupling element (waveguide lens array 211) may be accurately positioned (or plugged in) in a low cost manner compared to previous methods.

Note that the exemplary embodiments discussed herein refer to at least two waveguide core fiducials and at least two corresponding mating fiducials or alignment features. This approach is preferred, and optimally, there should be (at least) one fiducial on each side of the waveguide core(s). However, in some instances, one waveguide fiducial of appropriate shape, such as a rectangular shape, can be employed (with a single corresponding mating fiducial or alignment feature). The single fiducial can be positioned on one side of the waveguide cores, and should have a non-circular shape, so that it can determine location (including angular orientation) in the X-Y plane by itself. However, this single-fiducial approach is currently believed to be less preferred.

FIGS. 3-5 show the side, front, and top view of this improved coupling element alignment method of FIG. 2. Note turning mirror 230. For the case shown in FIG. 5, two waveguide core fiducials 222 are positioned adjacent to the waveguide core region. The waveguide fiducials 222 are, in this example, circular features. The waveguide lens array assembly contains two corresponding fiducials 220 that mate to the waveguide core fiducials 222. For the case shown, the waveguide lens array assembly 211 tests on the waveguide lower clad 212; this defines the Z position of the assembly. The X and Y position of the waveguide lens arrays assembly is precisely defined by the waveguide core fiducials 222. It is understood that the core fiducial shape may be other than

circular, for example square, rectangular, elliptical, triangular or any other shape. It is also understood that the one or more core fiducials **222** may be used at any other position(s) relative to the light carrying core region.

FIGS. **6-8** show alternate Z reference techniques. For the case in FIG. **6**, the coupling element Z position is defined by the tops of the waveguide core fiducials **222**. For the case is FIG. **7**, the coupling element Z position is defined by the top of the top cladding **216**. Note that in FIG. **7**, fiducials **222'** in the layer of waveguide cores **204** are female, and the corresponding alignment features **220'** in lens **211** are male. For the case in FIG. **8**, the coupling element Z position is defined by the top of the bottom cladding **212**.

FIGS. **9-11** show the alignment of an MT ferrule **902** to the waveguide film with waveguides **904**. FIG. **9** shows an end view of a modified MT ferrule **902** and of the waveguide film with waveguides **904**. Here, once again, waveguide core alignment fiducials **922** are formed adjacent to the waveguide core coupling region. A corresponding MT ferrule alignment feature **920** is formed to mate with the waveguide feature. As shown, the top of the waveguide cladding **916** may act as the Z position reference when mated with the MT ferrule assembly **902**. The modified MT ferrule may be fabricated by several techniques, one possible method being precision injection molding. In this case, a high degree of accuracy may be realized between the MT ferrule alignment holes **920** and the MT ferrule to waveguide alignment features **922**. FIG. **10** shows the final assembly of the MT ferrule **902** and the waveguide film with cores **904**. After assembly and bonding, the end of the MT ferrule assembly may be polished and sealed to ensure high optical coupling efficiency from the MT ferrule to a mating assembly. One appreciates that a high degree of alignment accuracy is realized between the MT ferrule alignment holes **920** and the waveguide cores. FIG. **11** is a pictorial view.

An inventive method of aligning an optical coupling element to a waveguide core thus includes the step of providing a waveguide assembly, the waveguide assembly comprising a core **204**, **904**, a cladding portion (such as **216**, **916**), and at least two waveguide core fiducials **222**, **222'**, **922** lithographically formed substantially simultaneously with the core **204**, **904**, the core and the at least two waveguide core fiducials being formed in a predetermined relationship with the cladding portion. The method also includes the step of providing an optical coupling element the optical coupling element comprising an optical element (for example, **211**, **902**) and at least two alignment features **220**, **220'**, **920** associated with the optical element, the at least two alignment features being configured to mate with the at least two waveguide core fiducials and to accurately position the optical element with respect to the core in an X-Y plane. The method further includes the step of plugging the at least two waveguide core fiducials **222**, **222'**, **922** and the at least two alignment features **220**, **220'**, **920** together, whereby the waveguide core **204**, **904** and the optical coupling element **202**, **902** are accurately positioned in the X-Y plane.

The core fiducials and the alignment features can, in some instances, be substantially round in cross-section. In other instances, one or more can have other shapes; for example, at least one of the core fiducials and at least a corresponding one of the alignment features might not be substantially round in cross-section; one or more could have other shapes or could have flats on them, or the like.

As shown in FIGS. **2-8**, the optical coupling element could be a lens array formed by element **211** with fiducials **220**. As shown in FIGS. **6-8**, the method could include the additional step of locating the lens array with respect to the waveguide

assembly in a Z-direction, for example, resting the lens array **211** on a top surface of the fiducials **204**, as in FIG. **6**; resting the lens array **211** on a top clad layer **216** of the waveguide assembly, as in FIG. **7**, or resting the lens assembly **211** on a bottom clad layer **212** of the waveguide assembly.

As shown in FIGS. **9-11**, the optical coupling element could be a mechanical transfer (MT) ferrule **902** with alignment features **920**. As best seen in FIG. **9**, in such case, the method could include the additional step of locating the MT ferrule **902** with respect to the waveguide assembly (including cores **904**) in a Z-direction. In one non-limiting example, the locating step includes resting a substantially planar surface **970** of the MT ferrule **902** on a top surface of the waveguide cladding portion **916**.

As discussed herein, for example, with respect to FIG. **2**, the step of providing the waveguide assembly can include providing a substrate **212**, **218**; depositing a waveguide layer **214** on the substrate; and lithographically forming the core(s) **204** and the at least two waveguide core fiducials **222** from the waveguide layer. In one or more embodiments, the cladding portion includes a bottom clad layer **212** and a top clad layer **216**; the substrate comprises a base substrate **218** and the bottom clad layer **212**; and the step of providing the waveguide assembly further includes applying the top clad layer **216** over the core(s) **204** and the at least two waveguide fiducials **222**, and removing material from the top clad layer adjacent the at least two waveguide fiducials.

An inventive optical assembly can include, by way of example and not limitation, a waveguide assembly, the waveguide assembly in turn comprising a core **204**, **904**, a cladding portion (such as **216**, **916**), and at least two waveguide core fiducials **222**, **222'**, **922**, the at least two waveguide core fiducials and the core being lithographically formed substantially simultaneously in a substantially coplanar layer, the core and the at least two waveguide core fiducials being formed in a predetermined relationship with the cladding portion. Also included is an optical coupling element, the optical coupling element in turn comprising an optical element **202**, **902** and at least two alignment features **220**, **220'**, **920** associated with the optical element, the at least two alignment features being mated with the at least two waveguide core fiducials to accurately position the optical element with respect to the core in an X-Y plane.

As previously discussed, the optical coupling element could include, for example, a lens array or an MT ferrule—these examples are not meant to be limiting. As discussed with regard to FIGS. **6-8**, the optical assembly can include a waveguide assembly Z-determining surface on the waveguide assembly and an optical coupling element Z-determining surface on the optical coupling element. The Z-determining surfaces are in substantial engagement to position the waveguide assembly and the optical coupling element in a predetermined relationship to one another in a Z-direction. In FIG. **6**, the waveguide assembly Z-determining surface includes top surfaces of the at least two fiducials **222**. In FIG. **7**, the waveguide assembly Z-determining surface includes a top clad layer **216** of the waveguide assembly. In FIG. **8**, the waveguide assembly Z-determining surface includes a bottom clad layer **212** of the waveguide assembly.

One or more embodiments of the present invention thus relate generally to integrated circuits, circuit packaging, circuit communication technologies, and particularly, but not by way of limitation, the mating of coupling elements to optical waveguide structures. One or more exemplary applications of inventive techniques accurately and cost effectively align these coupling elements in a passive manner using accurately defined waveguide fiducials, thus realizing a practical, accu-

rate, and low cost means to align OE devices, lens arrays, and other connector elements to polymer waveguide optical interconnect materials and the like. In the past, for optical interconnect systems, the alignment between the OE devices (or lens arrays) and the waveguide core was realized by actively aligning OE or coupling elements through the use of sophisticated tooling, powering up the OE devices, and monitoring the light coupled into the waveguide core. This process was time consuming and costly. With one or more exemplary embodiments of the present invention, one is able to utilize lithographic features that are patterned at the same time as the waveguide core to very accurately establish mechanical alignment fiducials. By using these fiducials during the assembly of the waveguide's connector elements, an extremely accurate assembly is realized in a passive manner

The techniques set forth herein can be used to make circuits realized on an integrated circuit chip. The chip design can be created, for example, in a graphical computer programming language, and stored in a computer storage medium (such as a disk, tape, physical hard drive, or virtual hard drive such as in a storage access network). If the designer does not fabricate chips or the photolithographic masks used to fabricate chips, the designer may transmit the resulting design by physical means (e.g., by providing a copy of the storage medium storing the design) or electronically (e.g., through the Internet) to such entities, directly or indirectly. The stored design can then be converted into an appropriate format such as, for example, Graphic Design System II (GDSII), for the fabrication of photolithographic masks, which typically include multiple copies of the chip design in question that are to be formed on a wafer. The photolithographic masks can be utilized to define areas of the wafer (and/or the layers thereon) to be etched or otherwise processed.

Resulting integrated circuit chips can be distributed by the fabricator in raw wafer form (that is, as a single wafer that has multiple unpackaged chips), as a bare die or in a packaged form. In the latter case, the chip can be mounted in a single chip package (such as a plastic carrier, with leads that are affixed to a mother board or other higher level carrier) or in a multi-chip package (such as a ceramic carrier that has either or both surface interconnections or buried interconnections). In any case, the chip may then be integrated with other chips, discrete circuit elements and/or other signal processing devices as part of either (a) an intermediate product, such as a mother board, or (b) an end product. The end product can be any product that includes integrated circuit chips, ranging from toys and other low-end or consumer electronic applications to advanced computer products. The techniques set for the herein can be used for interconnecting the chip on chips or chip stacks for 3D applications, chips on wafers, chips on package or package on package.

It will be appreciated and should be understood that the exemplary embodiments of the invention described above can be implemented in a number of different fashions. Given the teachings of the invention provided herein, one of ordinary skill in the related art will be able to contemplate other implementations of the invention.

Although illustrative embodiments of the present invention have been described herein with reference to the accompanying drawings, it is to be understood that the invention is not limited to those precise embodiments, and that various other

changes and modifications may be made by one skilled in the art without departing from the scope or spirit of the invention.

What is claimed is:

1. An optical assembly, comprising:

a waveguide assembly, said waveguide assembly in turn comprising a core, a cladding portion, and at least one waveguide core fiducial, said at least one waveguide core fiducial and said core being lithographically formed substantially simultaneously in a substantially coplanar layer, said core and said at least one waveguide core fiducial being formed in a predetermined relationship with said cladding portion;

an optical coupling element, said optical coupling element in turn comprising an optical element and at least one alignment feature associated with said optical element, said at least one alignment feature being mated with said at least one waveguide core fiducial to accurately position said optical element with respect to said core in an X-Y plane; and

at least a second waveguide core fiducial and at least a second corresponding alignment feature, such that there are at least two waveguide core fiducials and at least two alignment features mated together;

wherein said optical coupling element comprises a mechanical transfer (MT) ferrule.

2. An optical assembly, comprising:

a waveguide assembly, said waveguide assembly in turn comprising a core, a cladding portion, and at least one waveguide core fiducial, said at least one waveguide core fiducial and said core being lithographically formed substantially simultaneously in a substantially coplanar layer, said core and said at least one waveguide core fiducial being formed in a predetermined relationship with said cladding portion;

an optical coupling element, said optical coupling element in turn comprising an optical element and at least one alignment feature associated with said optical element, said at least one alignment feature being mated with said at least one waveguide core fiducial to accurately position said optical element with respect to said core in an X-Y plane;

at least a second waveguide core fiducial and at least a second corresponding alignment feature, such that there are at least two waveguide core fiducials and at least two alignment features mated together; and

a waveguide assembly Z-determining surface on said waveguide assembly and an optical coupling element Z-determining surface on said optical coupling element, wherein said Z-determining surfaces are in substantial engagement to position said waveguide assembly and said optical coupling element in a predetermined relationship to one another in a Z-direction.

3. The optical assembly of claim 2, wherein said waveguide assembly Z-determining surface comprises top surfaces of said at least two fiducials.

4. The optical assembly of claim 2, wherein said waveguide assembly Z-determining surface comprises a top clad layer of said waveguide assembly.

5. The optical assembly of claim 2, wherein said waveguide assembly Z-determining surface comprises a bottom clad layer of said waveguide assembly.

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